



AFGL
2822

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: William J. Schaff et al.

Title: AIN COATED HETEROJUNCTION FIELD EFFECT TRANSISTOR AND METHOD OF FORMING AN AIN COATING

Docket No.: 1153.044US1

Serial No.: 09/858,337

Filed: May 15, 2001

Due Date: October 6, 2005

Examiner: Khanh B. Duong

Group Art Unit: 2822

MS AF

Commissioner for Patents

P.O. Box 1450

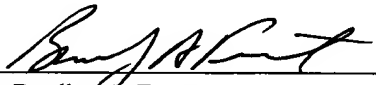
Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

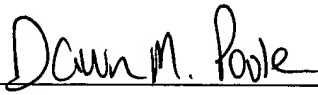
- ☒ Return postcard.
- ☒ Amendment and Response (9 pgs.).
- ☒ Petition for Extension of Time (1 pg.)
- ☒ Check in the amount of \$60.00 to cover the Extension of Time Fee.

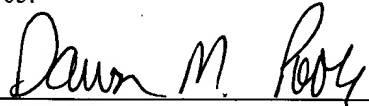
If not provided for in a separate paper filed herewith, Please consider this a **PETITION FOR EXTENSION OF TIME** for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.
Customer Number 21186

By: 
Atty: Bradley A. Forrest
Reg. No. 30,837

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 3rd day of October, 2005.


Name


Signature

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.
(GENERAL)